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Harrison
026159664

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. 09/233/377
Filing Date January 18, 1999
Inventor Gurtej S. Sandhu et al.
Assignee Micron Technology, Inc.
Group Art Unit 2813
Examiner T. Pham
Attorney's Docket No. MI22-1114
Title: Method of Forming a Refractory Metal Silicide (as Amended)

**PRELIMINARY AMENDMENT ACCOMPANYING A REQUEST FOR
CONTINUING EXAMINATION IN RESPONSE TO DECEMBER 19, 2001
FINAL OFFICE ACTION**

To: Box RCE
Assistant Commissioner for Patents
Washington, D.C. 20231

From: Frederick M. Fliegel, Ph.D.
Tel. 509-624-4276; Fax 509-838-3424
Wells, St. John, Roberts, Gregory & Matkin P.S.
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Spokane, WA 99201-3828

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TECHNOLOGY CENTER 2800

Responsive to the Final Office Action dated December 19, 2001,
Applicant amends and remarks as follows:

AMENDMENTS